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Saturability Algorithm of a Sub-Bandgap Laser for Triggering a Photoconductive Switch

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ABSTRACT Based on the experimental comparison of a GaN photoconductive semiconductor switch (PCSS) and two GaAs PCSSs, it is proposed that PCSSs made on heavily compensated sub-strates without the obvious optical frequency-doubling effect possess the laser-energy saturation threshold when triggered with a sub-bandgap laser. To this sort of PCSS, an algorithm is proposed for predicting the laser-energy saturability curves and the relevant saturation thresholds varying with the wavelength of a sub-bandgap laser. The algorithm is verified using the GaN:Fe PCSS experiment data.

INDEX TERMS Photoconductive switch, saturation, sub-bandgap, GaN, GaAs.

I. INTRODUCTION

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¹⁰ A PCSS operating in the linear mode [1], [2] triggered with 11 an ultra-fast power pulsed laser system is the best option 12 to simultaneously meet the needs of low triggering-jitter, 13 ultra-broadband, high power and electromagnetic interference (EMI) mitigation, especially when it is made on the 14 substrate with short carrier lifetime and high carrier mobility, 15 such as GaAs and GaN [3]-[6]. Recently, the usage of the sub-bandgap laser is getting enhanced attention, because it 17 not only relieves the current crowding and the flashover on 18 the surface of a traditional lateral PCSS, but also dramati-19 cally reduces the cost and the volume of the laser system of 20 wide-bandgap PCSS [2], [6]. It is known that the amplitude fluctuation of power pulsed lasers is generally more 22 than 5%, and the jitter of the photocurrent-pulse peak val-23 ues of PCSSs is mainly caused by the inevitable amplitude 24 fluctuation of the laser energy [7]. If there exists a laser-25 energy saturation threshold of the two-photon absorption 26 response to the PCSSs triggered by a sub-bandgap laser, the 27 laser-energy supersaturation will keep the photocurrent peaks 28 greatly stabilized [8], [9]. However, for a laser with a certain 29 wavelength in a certain operation mode, the higher demand 30 31 on the single-pulse laser-energy maximum usually means the ₃₂ higher cost, the greater volume and the heavier weight of the laser. The cost and the portability of the whole photocon-34 ductive switch system depend mainly on those of the laser. 35 Therefore, the photoelectric-transformation saturation depth (i.e., laser-energy saturability mentioned in this paper) is an ³⁶ important parameter to optimize the laser energy for reaching the best balance between the photocurrent-peak stability, ³⁸ the cost, and the system portability. ³⁹

Regarding the two-photon absorption response in PCSSs, 40 there are two physical mechanisms: one is the two-photon 41 simultaneous absorption due to the optical frequency-42 doubling (OFD) effect caused by the second harmonic of 43 nonlinear optics [10], [11], such as in GaAs or LiNbO₃ frequency doubling crystals; the other is the two-step photon 45 absorption via a deep energy level in the forbidden band regarding as a "ladder" to the photon-excited electrons, such 47 as the iron energy levels in GaN:Fe PCSSs or the vanadium 48 energy levels in SiC:V PCSSs [2], [8]. In this paper, first 49 it is discussed which sort of PCSSs can possess the laser-50 energy saturation threshold if triggered by a sub-bandgap 51 laser, through experimentally comparing a GaN:Fe PCSS 52 without the OFD effect and two GaAs:EL2 PCSSs with the 53 obvious OFD effect. Next, only to the sort of PCSSs without 54 the OFD effect, an algorithm is proposed for predicting the 55 laser-energy saturability and the relevant saturation threshold 56 varying with the wavelength of the sub-bandgap laser. 57

II. COMPARATIVE EXPERIMENTS

Two GaAs PCSSs were fabricated on a 0.6-mm-thickness 58 piece of unintentionally-doped (100) GaAs substrate 59 grown with the liquid-encapsulated czochralski method. 60

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61 The Au/Ge/Ni alloy electrodes are of ohmic contact and $_{62}$ the plain size of each electrode is 6.0 mm $\times 4.0$ mm. The electrode distance from the anode to the cathode of a PCSS is called the electrode gap. The electrode gaps 64 65 of the two PCSSs are 0.5 mm and 1.5 mm, respectively. The measurement circuit is demonstrated in Fig. 1. The 66 0.5-mm-gap and the 1.5-mm-gap PCSSs are biased at 5 V 67 and 11.7 V (i.e., 100 V/cm and 78 V/cm), respectively. The electron mobility of the substrate is approximately above 69 5500 cm²/(V·s). The two GaAs PCSSs are tested with a 7-ns-pulsewidth 1064-nm-wavelength Nd:YAG laser, and the 71 72 relevant photocurrent waveforms are demonstrated in Fig. 2. The relationship curves of the photocurrent-pulse peak val-73 ues and the single-pulse laser energy are measured as shown 74 in Fig. 3. It is noted that, there is an energy level of 0.76 eV 76 below the GaAs conduction band, named EL2, caused by ⁷⁷ the V_{Ga}-As_{Ga}-V_{Ga} point defects [12]. When the GaAs crystal growing, the unintentionally-introduced shallow acceptors (such as C on As-site) are highly compensated by the 79 unintentionally-introduced EL2 deep donors, which is called 80 self-compensation mechanism and leads to the high sub-81 strate resistivity (more than $5 \times 10^7 \cdot \Omega$ cm). The EL2 levels 82 are the dominant ladders to the two-step photon absorp-83 tion when triggered with a sub-bandgap laser, since the 84 EL2 concentration is about 2×10^{16} cm⁻³. 85

The 10-mm-gap GaN PCSS, fabricated by the 86 87 Kyma Technologies, Inc., is made on a piece of freestanding wurtzite GaN substrate [6]. The substrate is grown on the lat-89 tice buffer layers from the (0001) sapphire Al_2O_3 to the AlN, with the hydride vapor phase epitaxy (HVPE) method [13]. It is noted that, iron ions with the concentration of about 01 10^{18} cm⁻³ have been doped when the GaN crystal grow-92 ing, as a sort of deep-energy-level acceptor to compensate 93 94 the unintentionally-introduced shallow donors mainly due to the O-on-N-sites, Si-on-Ga-sites and N-vacancies [14], [15]. The Fe heavy doping not only makes the substrate resistivity 96 more than $1 \times 10^9 \Omega \cdot cm$, but also brings the abundant deep 97 energy levels for the two-step photon absorption of the GaN PCSS triggered with a sub-bandgap pulsed laser. The elec-99 tron mobility is about 3×10^2 cm²/(V·s) and the bias voltage is 1 kV (i.e., its electric field is 1 kV/cm), so the aver-101 age drift velocity of the photo-generated electrons in the GaN:Fe PCSS is as the same order of magnitudes, 10⁵ cm/s, 103 as those in the two GaAs:EL2 PCSSs. The experiment circuit 104 and the measurement results have been reported in [6]. The 105 data points on the relationship of the photocurrent-pulse peak 106 values and the single-pulse laser energy are demonstrated in 107 Fig. 4. Moreover, 12 data points on the extrinsic absorp-108 tion coefficient of the GaN:Fe PCSS substrate material are 109 demonstrated in Fig. 5. 110

III. ANALYSIS AND DISCUSSION

¹¹¹ In the GaN:Fe PCSS experiment, there is an obvious laser-¹¹² energy saturation threshold at about 1.55 mJ (see Fig. 4). It ¹¹³ means that, when the laser energy is more than the thresh-¹¹⁴ old the On-state resistance of the PCSS device is not able



FIGURE 1. Schematic diagram of the GaAs PCSS experimental circuit. The Au/Ge/Ni ohmic electrodes of the PCSS are connected to the microstrips made on a copper-clad Al₂O₃ plate.



FIGURE 2. 20-time-overlap photocurrent waveforms of the 1.5-mm-gap GaAs PCSS biased at 78 V/cm triggered with a 7-ns-pulsewidth 1064-nm-wavelength Nd:YAG laser.

to continue decreasing with the laser energy increasing. The On-state resistance closely depends on the photon absorption amount of the PCSS operating in linear mode [2] when the conditions of the laser and the bias electric field hold changeless. GaN is regarded as a material without the OFD effect in general engineering applications. The two-photon absorption response to the GaN PCSS is of the two-step photon absorption through the Fe deep energy levels in the forbidden band. When the deep energy levels in the light path of the PCSS have been used up, the photocurrent-pulse peak does not keep increasing with the laser energy. 125

In the GaAs:EL2 PCSS experiment, there is no laser- 126 energy saturation threshold but there is an obvious curve 127 inflection point at about 0.17 mJ (see Fig. 3). When less 128 than the curve inflection point, the peak-value increasing 129 with the laser-energy is rapid, because both the two-step 130 photon absorption (due to the EL2 deep energy levels) 131 and the two-photon simultaneous absorption (turning every 132 two 1064-nm-wavelength photons into a 532-nm-wavelength 133 photon) are working. When more than the curve inflection 134 point, the peak-value increasing with the laser-energy is slow, 135 because the EL2 deep energy levels on the light path have 136 been used up for the two-step photon absorption. Therefore, 137 the subsequent slow increment is only contributed by the 138 OFD effect. Theoretically, the increment due to the OFD 139 effect will continue until the concentration of the photo- 140 generated carriers has reached up to make the carrier mobility 141

¹⁴² greatly decreased due to the Coulomb scattering effect or has
¹⁴³ reached up to that the substrate is unable to absorb more
¹⁴⁴ photons due to the spectral hole burning effect [16], [17]
¹⁴⁵ based on the Pauli's exclusion principle.



FIGURE 3. Relationship of the photocurrent-pulse peak values of the GaAs PCSSs and the single-pulse energy of the 7-ns-pulsewidth 1064-nm-wavelength laser. The 0.5-mm-gap and the 1.5-mm-gap PCSSs are biased at 100 V/cm and 78 V/cm, respectively. Every data point of the GaAs experiment is the mean value of 20 times measurement.

Through the above experimental comparison, it is proposed that, PCSSs made on heavily-compensated substrates without the ODF effect can possess the laser-energy saturation threshold when triggered with a sub-bandgap laser. For this sort of PCSS, an algorithm on saturability and threshold is proposed in the following.

The optical intensity distribution along the incident direction (z) in a PCSS is given by the following:

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$$I(z) = I_{(z=0)} \exp^{-\alpha z}$$
 (1)

¹⁵⁵ where α is the absorption coefficient of the PCSS substrate ¹⁵⁶ crystal. To a heavily-compensated substrate without the OFD ¹⁵⁷ effect, there is a dominant deep energy level and only the ¹⁵⁸ two-step photon absorption via the dominant deep level needs ¹⁵⁹ to be considered. Therefore, the optical absorption coefficient ¹⁶⁰ to sub-bandgap wavelength (λ) is given by

$$\lim_{161} \alpha(\lambda) = \ln\left[\frac{m(\lambda)}{m(\lambda) - N_d}\right] \text{ when } \lambda < \frac{1.24 \ \mu\text{m} \cdot \text{eV}}{\max(E_d, \ E_g - E_d)}$$

$$\lim_{162} (2)$$

¹⁶³ where *m* is the photon amount of an incident laser pulse per ¹⁶⁴ unit light path, N_d is the effective amount of the dominant ¹⁶⁵ deep energy level per unit light path, E_g is the forbidden-¹⁶⁶ band width and E_d is the dominant deep energy level below ¹⁶⁷ the conduction band of the substrate material.

In the case of the GaN:Fe PCSS, the Fe³⁺ energy level is dominant among all kinds of the two-step photon-absorption ladders, because its density is at least two orders of magnal nitude higher than the other energy-level densities of the shallow donors and acceptors [18]. Since the Fe³⁺ level is 1.299 eV [18] below the conduction band of GaN and the GaN forbidden bandwidth is 3.42 eV, the upper limit of the



FIGURE 4. Relationship of the photocurrent-pulse peak values and the single-pulse laser energy when triggering the GaN:Fe PCSS with the bias electric field of 1 kV/cm, the laser pulsewidth of 5 ns and the wavelength of 532 nm [6].

laser wavelength for the two-step photon absorption is about 175 585 nm (i.e., 3.42eV minus 1.299 eV) based on (2).

When measuring the $\alpha(\lambda)$ curve of substrate materials, 177 usually the laser single-pulse energy (W) and the pulsewidth 178 are constant. Supposing this used laser energy as W_0 , the 179 two parameters in (2) can be given by 180

$$n(W, \lambda) = \frac{W}{2\mathrm{hc}/\lambda}$$
, $N_{\mathrm{d}} = \frac{W_0}{2\mathrm{hc}/\lambda_{\mathrm{d}}}$ (3) 181

where *h* is the Planck constant, *c* is the speed of light in ¹⁸² vacuum, and λ_d is the effective wavelength just making the ¹⁸³ crystal absorption of unit light path critically saturated. Based ¹⁸⁴ on (2) and (3), the absorption coefficient is deduced to be ¹⁸⁵

$$\alpha (\lambda) = \operatorname{In}\left(\frac{\lambda}{\lambda - \lambda_d}\right).$$
(4) 186

Based on (4) and a few of absorption-coefficient experimental data points (such as the points shown in Fig. 5), the value of λ_d can be obtained using the curve-fitting method. Based on (3), the laser-energy saturability of the PCSS varying with the energy and the wavelength of the triggering laser is given by

$$\eta(W,\lambda) \stackrel{def}{=} \frac{m(W,\lambda)}{N_d} = \frac{W\lambda}{W_0\lambda_d}.$$
 (5) 193

The saturation threshold is the laser-energy value at $^{194}\eta$ =100%.

In the case of GaN:Fe PCSS, the value of λ_d , 405.996 nm, ¹⁹⁶ is calculated out using the curve-fitting method based on (4) ¹⁹⁷ with the experimental data of Fig. 5. The effectiveness of ¹⁹⁸ the curve fitting is demonstrated in Fig. 5, which stan- ¹⁹⁹ dard deviation is 0.11 cm⁻¹. The curve fitting deviation ²⁰⁰ slightly increases after the wavelength is greater than 500 nm, ²⁰¹ because the thermal absorption effect is ignored in the above ²⁰² equations. Base on (5) and the λ_d value above, the satura- ²⁰³ bility curves of the GaN:Fe PCSS varying with laser energy ²⁰⁴ under different wavelengths are calculated and the results are ²⁰⁵ shown in Fig. 6. Therefore, the laser-energy saturation threshold of the GaN:Fe PCSS triggered by a 5-ns-pulsewidth ²⁰⁷



FIGURE 5. Absorption coefficient curve of the GaN:Fe PCSS substrate material. The 12 data points of absorption coefficient are measured using a frequency tripled line (355 nm) of the 5-ns-pulsewidth laser and an optical parametric oscillator (OPO) to vary the wavelength of the output light. Note that the laser energy illuminating on the substrate material is always 2 mJ to each wavelength of the 12 data points [6]. The red-color dashed curve is fitted based on (4) using the 12 data points.



FIGURE 6. Laser-energy saturability of the GaN:Fe PCSS. The curves are calculated, based on (5) where $\lambda_d = 405.996$ nm and $W_0 = 2$ mJ. The ' ∇ ' symbol marks the predicted saturation threshold when the PCSS is triggered with a 5-ns-pulsewidth 532-nm-wavelength laser.

²⁰⁸ sub-bandgap laser can be predicted. As shown in Fig. 6, the ²⁰⁹ calculated laser-energy threshold should be 1.52 mJ when ²¹⁰ the laser wavelength is 532 nm, which calculated threshold ²¹¹ is in approximate agreement with the measured threshold of ²¹² the GaN PCSS experiment shown in Fig. 4.

IV. CONCLUSION

²¹³ Through experimentally comparing the GaN:Fe PCSS and ²¹⁴ the GaAs:EL2 PCSSs, it is demonstrated that there exists ²¹⁵ a laser-energy saturate threshold to a PCSS if the PCSS ²¹⁶ triggered with a sub-bandgap laser is made on a heavily-²¹⁷ compensated substrate without the obvious ODF effect. ²¹⁸ Furthermore, to such sort of PCSS an algorithm is proposed ²¹⁹ for predicting the photoelectric-transformation saturation depth varying with the laser energy and the relevant saturation threshold under different wavelength conditions. The prediction method only needs to actually measure a few of data points on the absorption coefficient curve of the PCSS's substrate material, using a laser that has the same energy and the same pulsewidth as those of the laser triggering the PCSS. The prediction is relatively simple but is helpful to design a PCSS system with a good balance between the photocurrent-peak stability, the cost and the portability. 228

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